

Notice of Reference. Cited

Application Control No.

09 615 999

Applicant's Patent Under

Reexamination
ZHANG ET AL

Examiner

Brian K Talbot

Art Unit

1762

Page 1 of

U.S. PATENT DOCUMENTS

* A	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-5723214 A	03-1998	Konishi et al	117194
B	US-			
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D	US-			
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K	US-			
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M	US-			

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NON-PATENT DOCUMENTS

* A	Include as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages)
A	Roster et al. Influence of the surface treatment on the homoepitaxial growth of SrTiO ₃ Material Science & Engineering, vol. B50 pp 209-212 1998
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2. The applicant hereby certifies that the information furnished in this Notice of References Cited is true and correct. See MPEP § 707.05(b).